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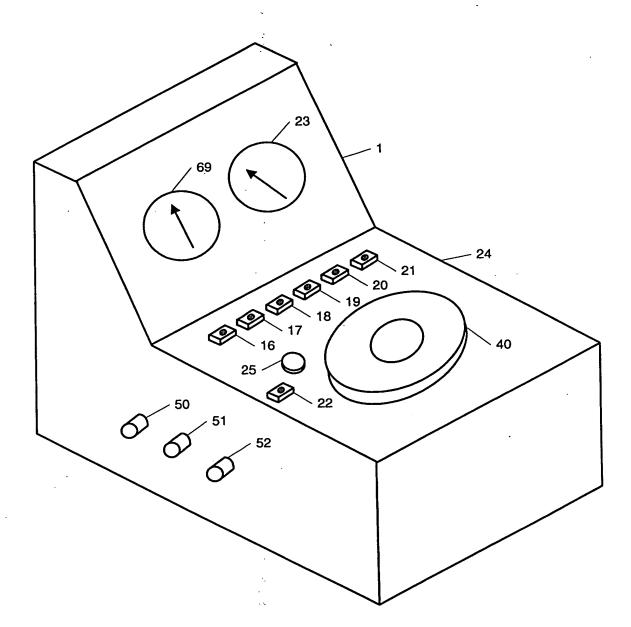


FIG. 1

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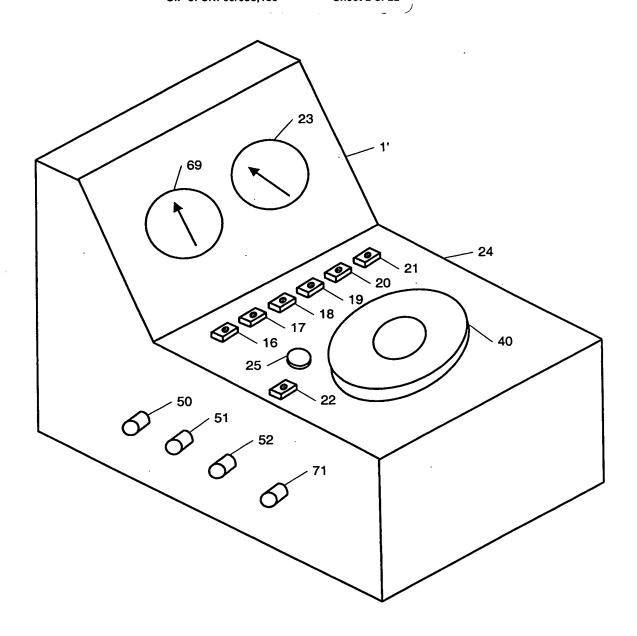
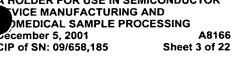
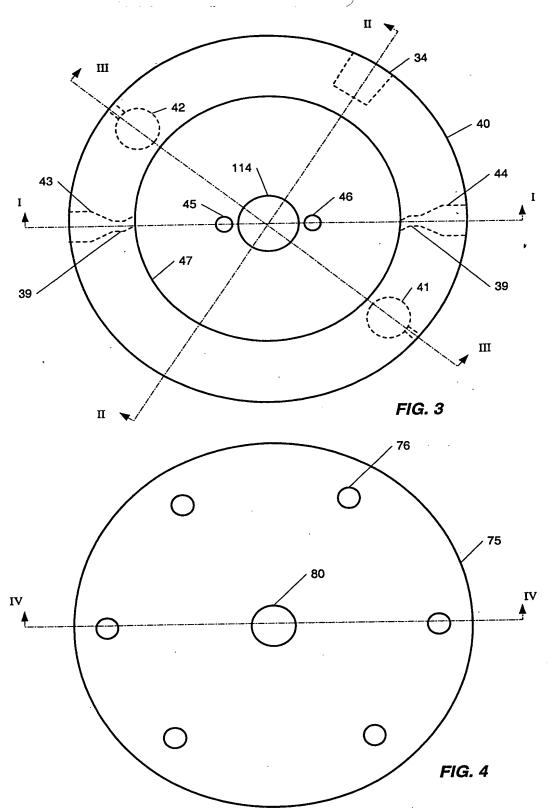


FIG. 2

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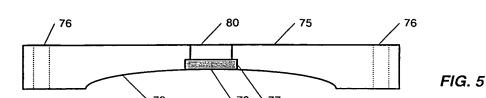


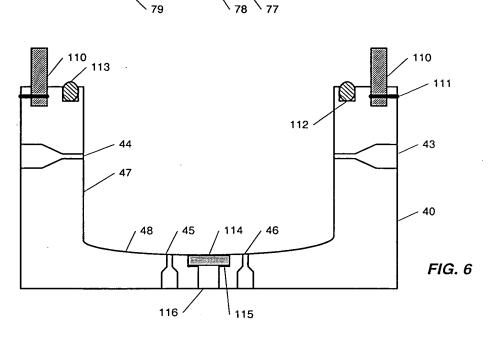


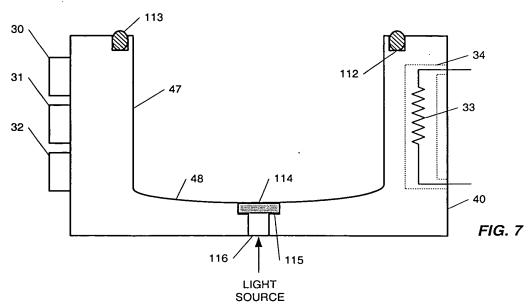
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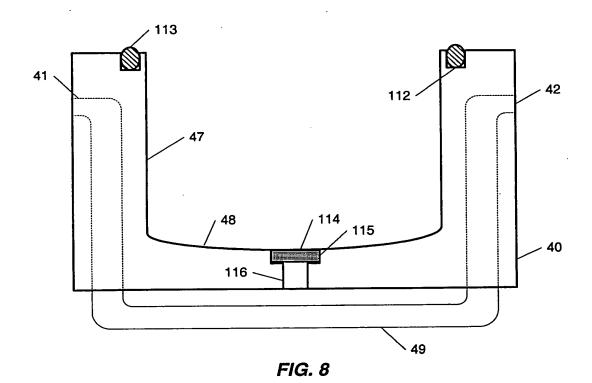




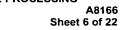


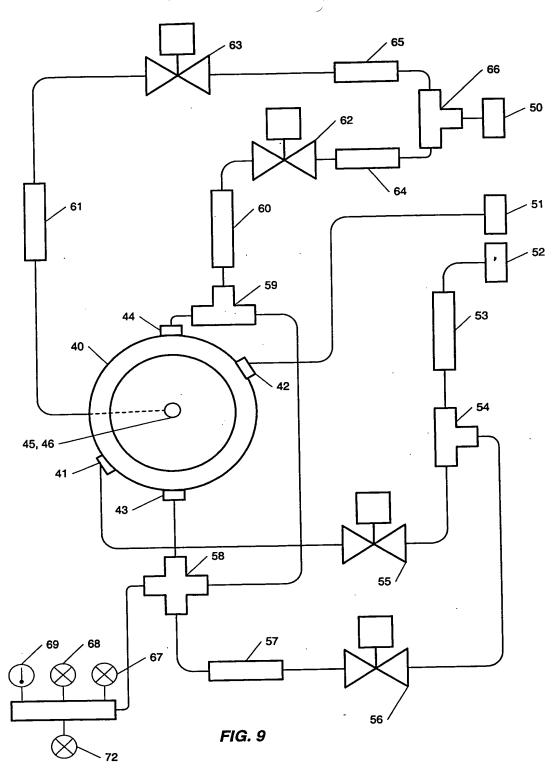
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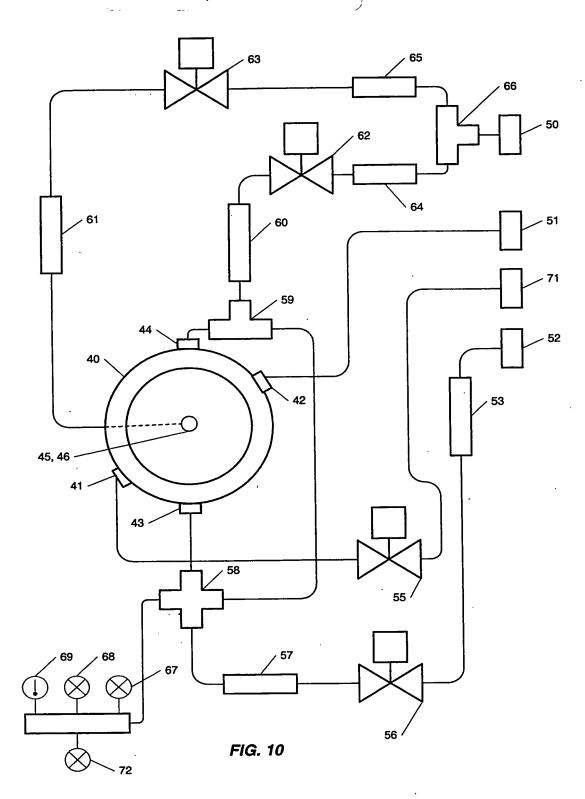


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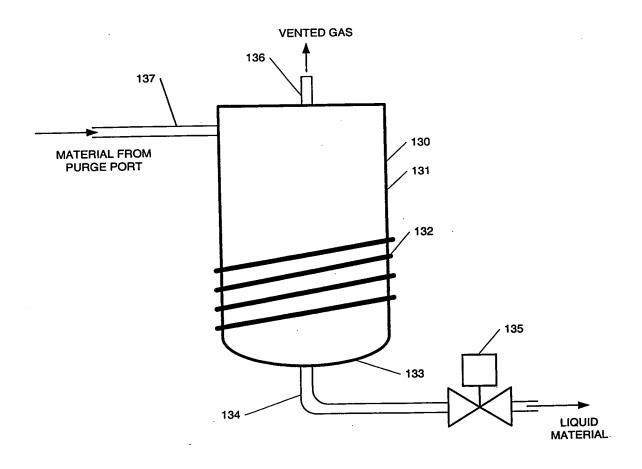


FIG. 11

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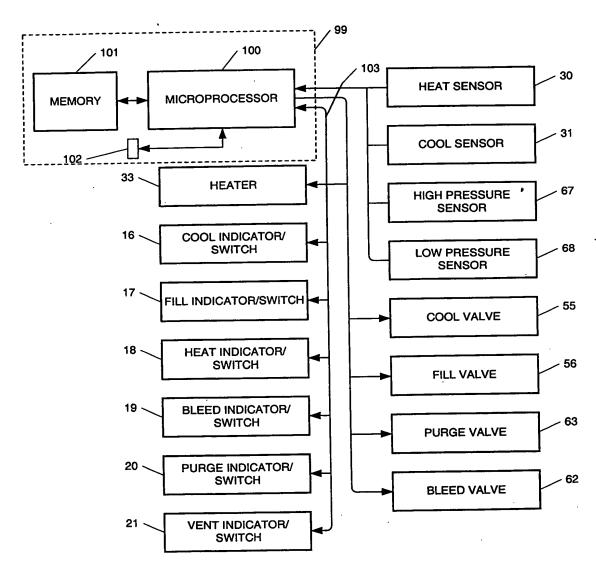
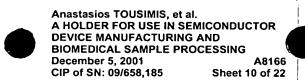
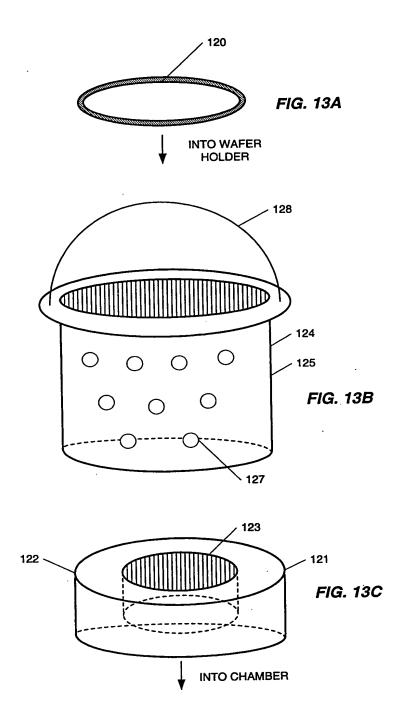


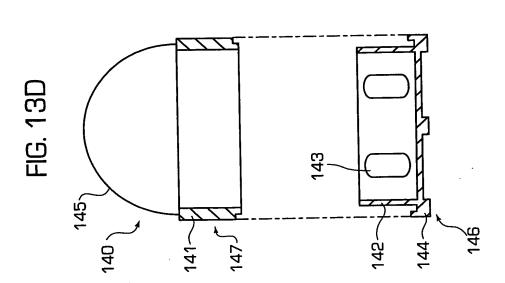
FIG. 12





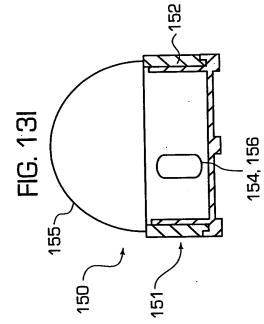
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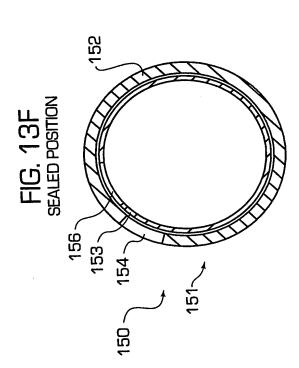
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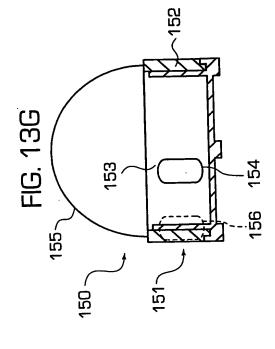


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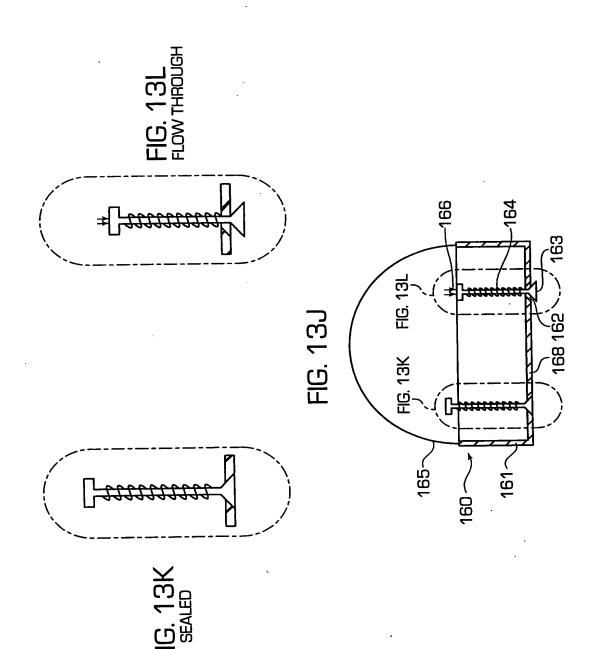






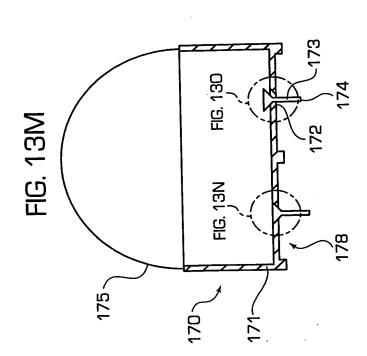
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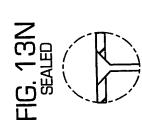
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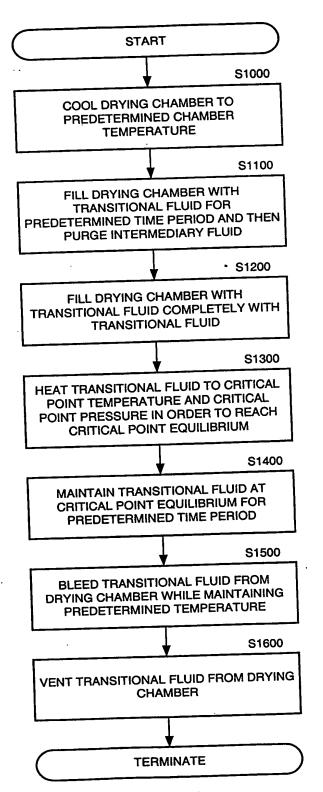


FIG. 14

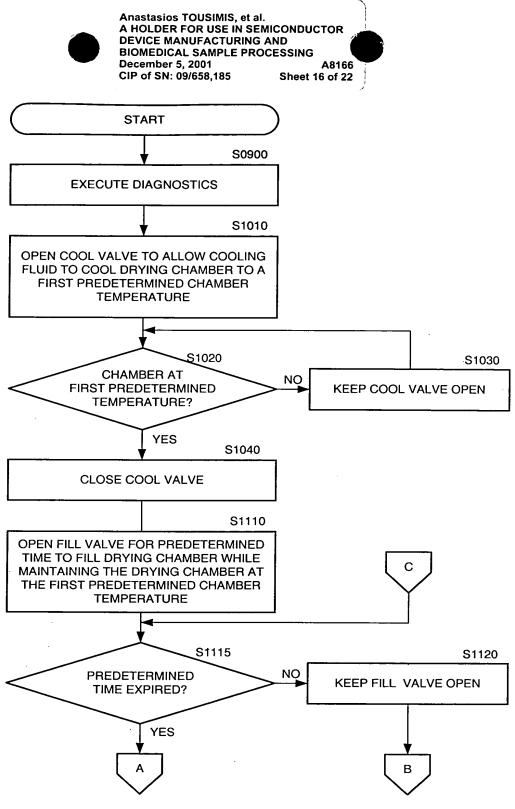
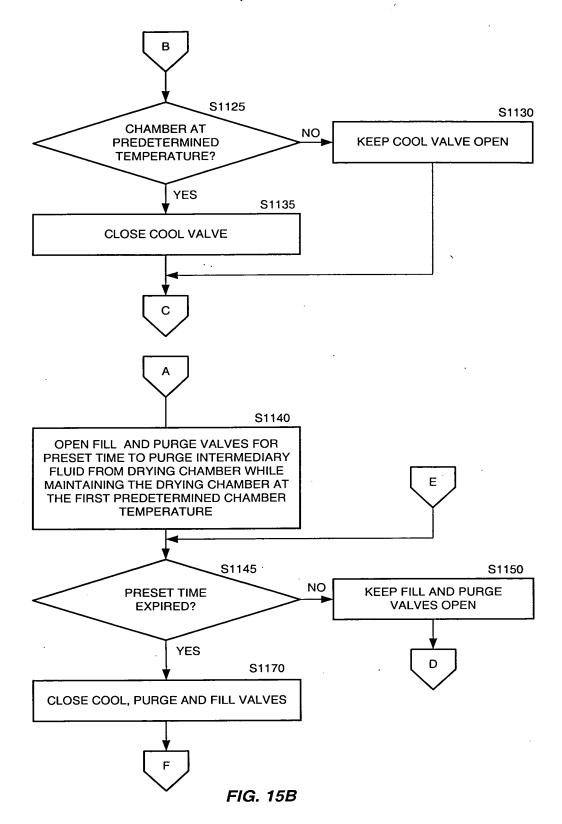


FIG. 15A

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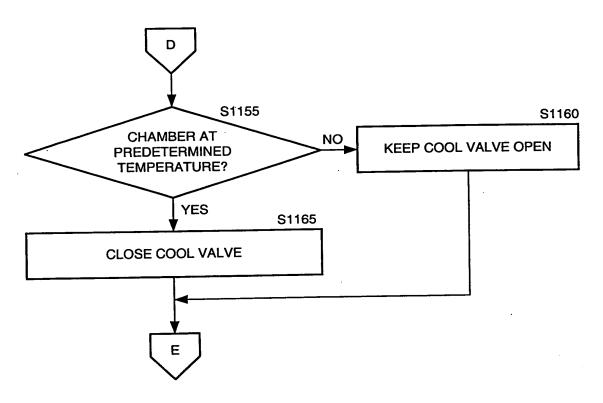


FIG. 15C

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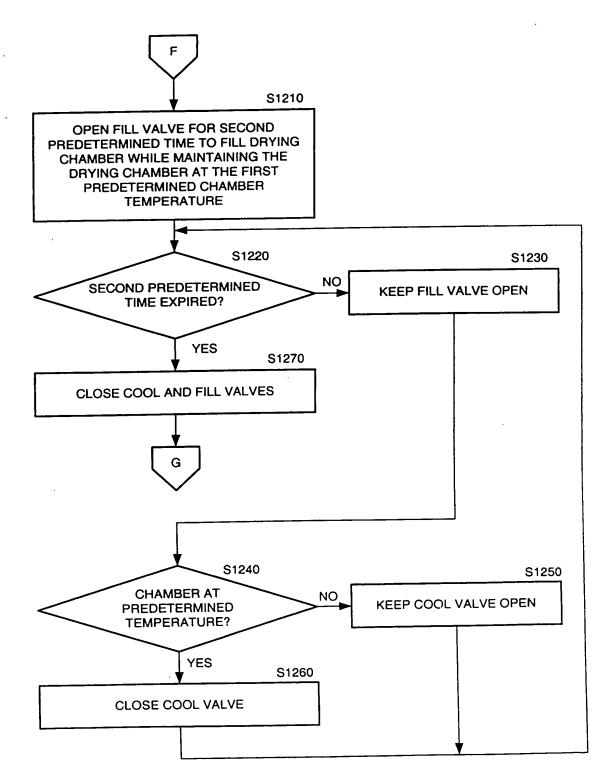
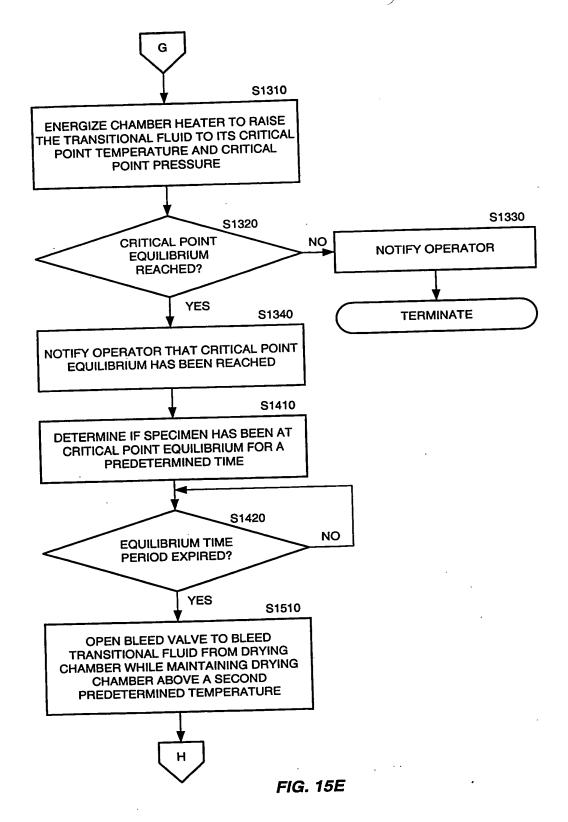


FIG. 15D



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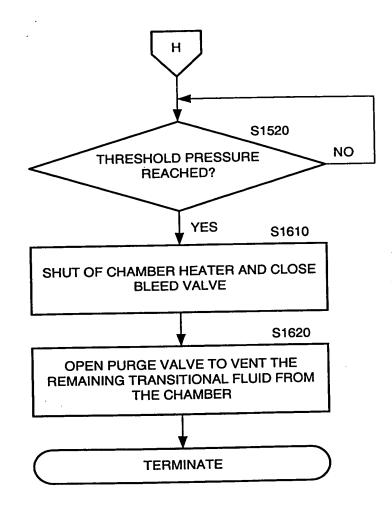


FIG. 15F



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							<del></del>					7	
VALVE OPERATIONS	VALVE OF ETATIONS	COOL VALVE STAYS OPEN UNTIL CHAMBER TEMPERATURE < 5º C	PRESET BASED ON CHAMBER SIZE; COOL VALVE CYCLES TO KEEP CHAMBER TEMPERATURE < 5º C	PARCET BY OPERATOR: COO! VALVE	CYCLES TO KEEP CHAMBER TEMPERATURE < 5° C	PRESET BASED ON CHAMBER SIZE; COOL VALVE CYCLES TO KEEP CHAMBER	TEMPERALURE < 3. C		BI FFD VALVE CLOSES WHEN PRESSURE	< 400 PSI	DI IDGE VAI VE STAYS OPEN UNTIL	POWER IS TURNED OFF	
BLEED	VALVE	CLOSED	CLOSED		CLOSED	CLOSED		CLOSED		OPEN		CLOSED	
PURGE	VALVE	CLOSED	CLOSED		OPEN	CLOSED		CLOSED	CLOSED			OPEN	
FILL	FILL		OPEN		OPEN	OPEN		CLOSED	CLOSED		CLOSED		
COOL	COOL		AS NEEDED		AS NEEDED	AS NEEDED	AS NEEDED		CLOSED			CLOSED	
	MODE		FILL (1)		PURGE	FILL (2)		TARL	חבאו	BLEED		VENT	

FIG. 1